

FORM 1449* FORTY-FIFTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT		Docket Number: 60001.0049US01/154685.01	Application Number: 09/841,265
IN AN APPLICATION (Use several sheets if necessary)		Applicant: Jeff Reynar	
		Filing Date: April 24, 2001	Group Art Unit: 2626

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,287,448	02.1994	Nicol et al.	715	707	
	5,535,323	07.1996	Miller et al.	715	707	
	5,546,521	08.1996	Martinez	715	711	
	5,581,684	12.1996	Dudzik et al.	715	708	
	5,715,415	02.1998	Dazey et al.	715	708	
	5,933,139	08.1999	Feigner et al.	715	708	
	5,933,140	08.1999	Strahom et al.	715	712	
	5,940,614	08.1999	Allen et al.	717	120	
	6,246,404 B1	06.2001	Feigner et al.	715	708	
	6,857,103 B1	02.2005	Wason	715	709	
	7,024,658 B1	04.2006	Cohen et al.	717	117	
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
	JP 08-272662	10.1996	Japan (w/ English language Abstract)			
	JP 2000-231566	08.2000	Japan (w/ English language Abstract)			
	JP 2000-222394	08.2000	Japan (w/ English language Abstract)			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
		Shiroiwa, K., "iMac&iBook, Must-see for User, Full of Recommended Setting Methods and Specially Selected Tips, Mastering Mac OS9", MacPeople, ASCII Corporation, Japan, December 3, 1999, vol. 5, no. 24, p. 50 (in Japanese - no translation yet)				
		(Previously cited) Koyaku, H., "What is Brought to SQL Server 2000 by XML, Part 1: Function of XML Provided by SQL Server 2000", Enterprise Servers World, Vol. 3, No. 12, IDG Japan, Inc., December 1, 2000, pp. 42-53 (with English language translation)				
		U.S. Final Office Action dated January 22, 2009 cited in Application No. 10/366,141				

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EXAMINER	DATE CONSIDERED
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U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	7,100,115 B1	08.2006	Yennaco	715	748	
	2004-0006564	01.2004	Lucovsky et al.	707	10	
	6,415,304 B1	07.2002	Horvitz	715	205	
	6,510,504 B2	01.2003	Satyanarayanan	711	170	
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
	JP 2001-014303	01.2001	Japan (w/ English language Abstract)			
	JP 2001-522112	11.2001	Japan (w/ English language Abstract)			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
		U.S. Office Action dated February 4, 2009 cited in Application No. 10/377,258				
		U.S. Final Office Action dated March 4, 2009 cited in Application No. 10/780,376				
		European Summons to Attend Oral Proceedings dated February 26, 2009 cited in European Application No. 0301283.0-2211 (60001.0182EP01)				
		European Communication dated March 18, 2009 cited in European Application No. 04003683.2-2211 (60001.0216EP01)				
		European Summons to Attend Oral Proceedings dated March 20, 2009 cited in European Application No. 03012830.0 (60001.0182EP01)				
		Japanese Official Action dated February 6, 2009 cited in Japanese Application No. 2003-180218 (60001.0190JP01)				
		Japanese Official Action dated February 13, 2009 cited in Japanese Application No. 2003-162911 (60001.0181JP01)				
		Japanese Official Action dated February 24, 2009 cited in Japanese Application No. 2003-161338 (60001.0182JP01)				
		Japanese Official Action dated March 6, 2009 cited in Japanese Application No. 2004-042140 (60001.0216JP01)				



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